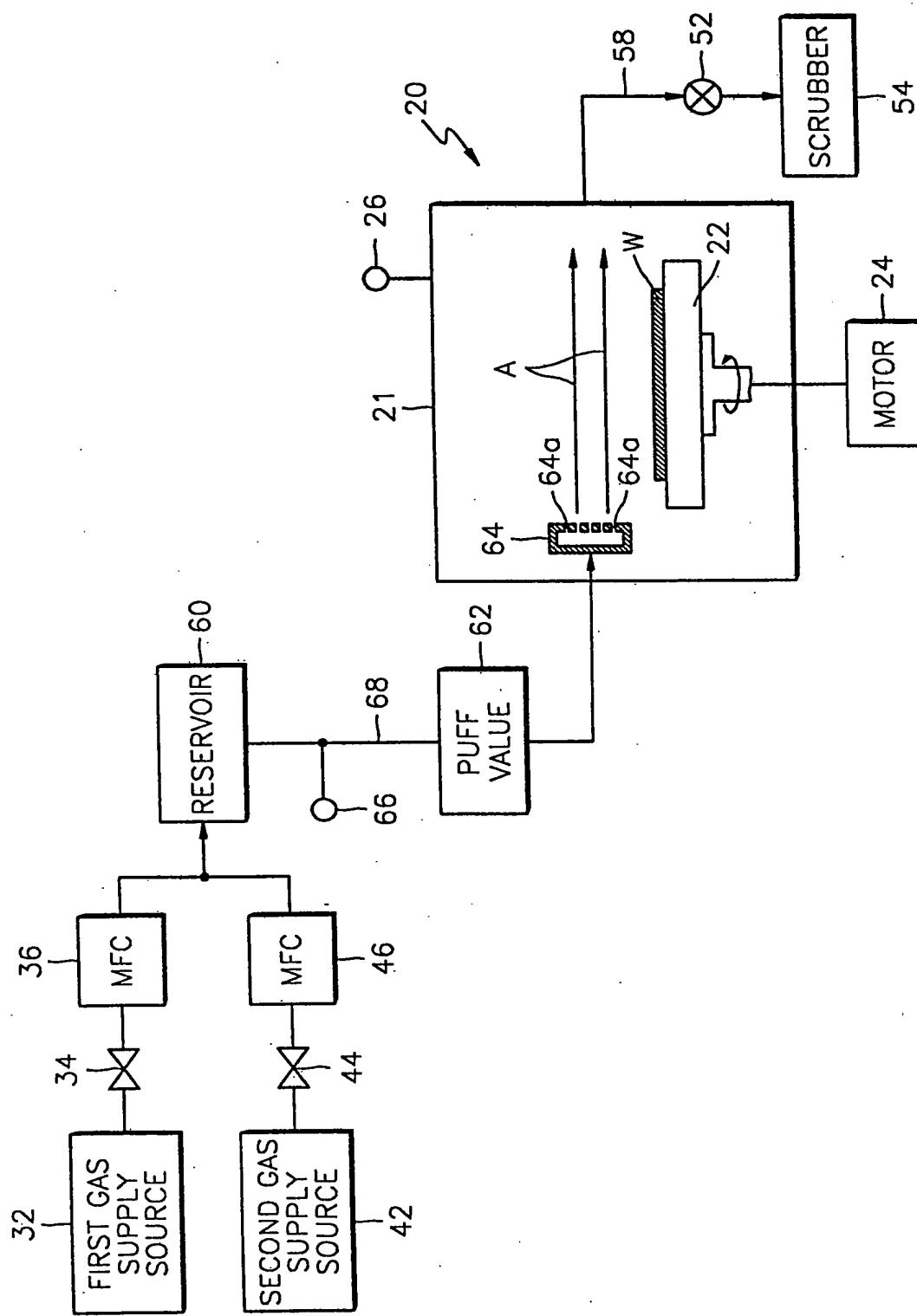


METHOD OF AND APPARATUS FOR MANUFACTURING A SEMICONDUCTOR DEVICE
USING A POLYSILICON HARD MASK
Application No. [New] – Attorney Doc. No. SEC.761D
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FIG. 1



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FIG. 2A

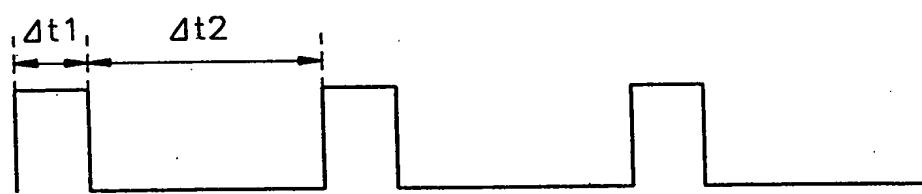


FIG. 2B



FIG. 3A

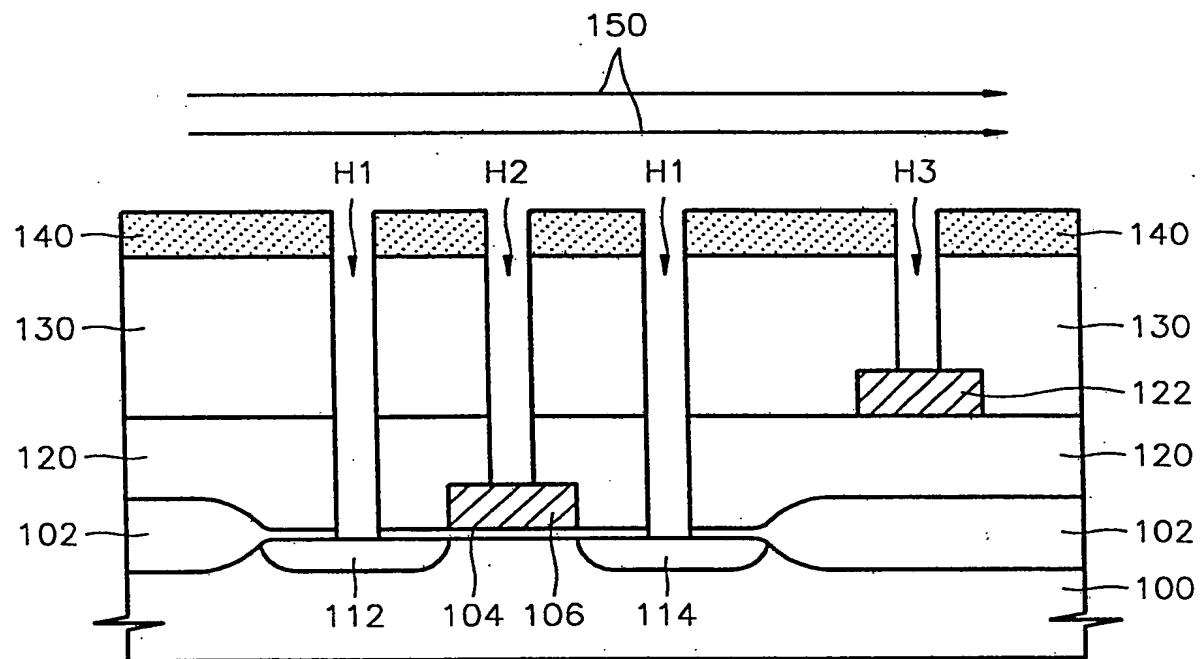
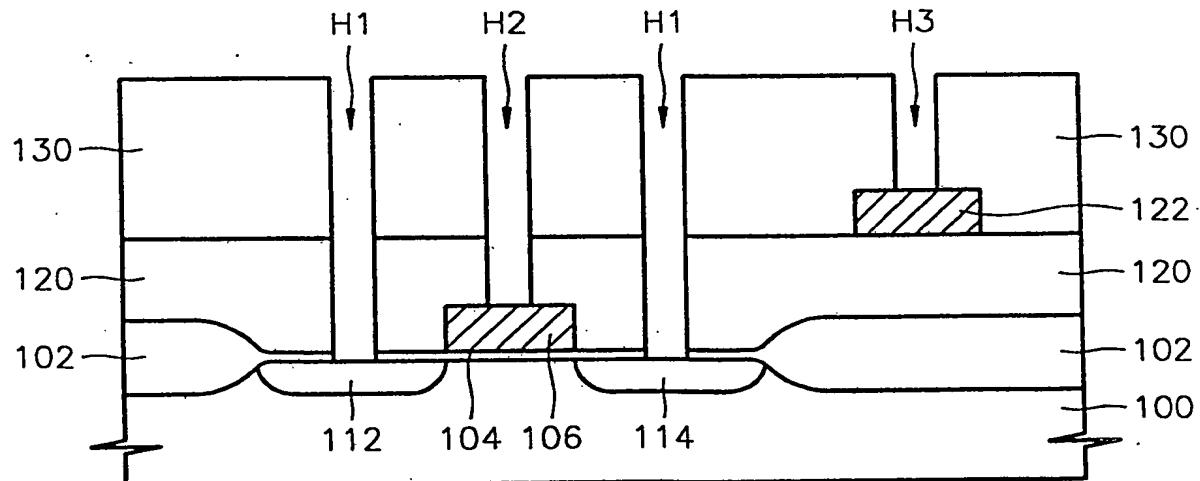


FIG. 3B



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FIG. 4A

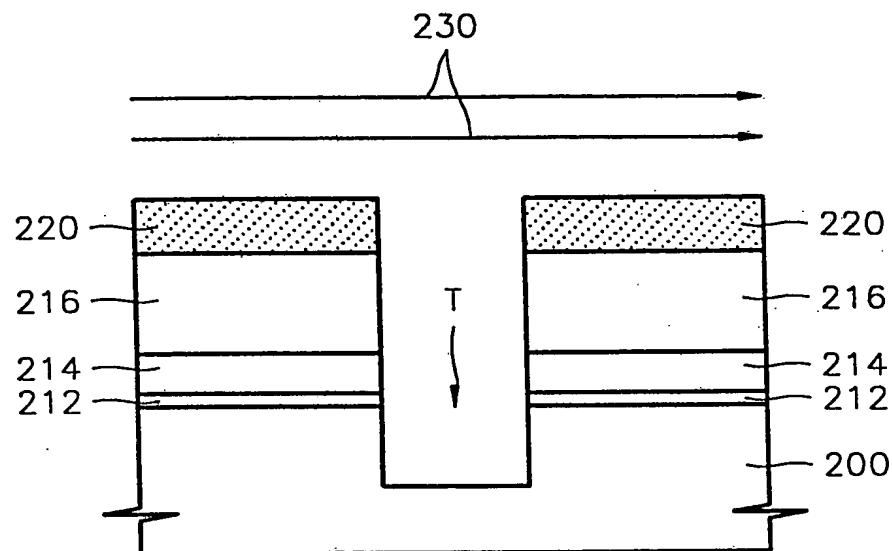


FIG. 4B

